IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Glenn A. Rinne

not yet assigned Serial No.:

Filed:

concurrently herewith

For:

METHODS OF POSITIONING COMPONENTS USING LIQUID PRIME MOVERS

AND RELATED STRUCTURES

Date: November 9, 2001

Commissioner for Patents Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Attached is a list of documents on form PTO-1449 together with a copy of each identified document. It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. § 1.97 and Section 609 of the MPEP. The Commissioner is hereby authorized to charge any additional fee, which may be required, or credit any refund, to our Deposit Account No. 50-0220.

Respectfully submitted

Registration No. 38,176

Correspondence Address:

PATENT TRADEMARK OFFICE

"Express Mail" mailing label number EL 920740102 US Date of Deposit: November 9, 2001

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to Box, Commissioner of Patents, Washington, DC 20231.

	Patent OF DOC	.S. Department of and Trademark O UMENTS CITED	BY APPLIC	Attorney Docket Number 9180-9			Serial No. not yet assig & d	
(Use several sheets if necessary)					Applicants: Glenn A. Rinne			10/01 10/01
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			U. S.	PATENT DO	CUMENTS			
Examiner Initial		Document Number Date		N	Jame	Class Subclass		Filing Date if Appropriate
			FORE	IGN PATENT	DOCUMENTS			
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		OTHER DO	CUMENTS (Including Auth	or, Title, Date, P	ertinent Page	es, Etc.)	
	1. A. Powell et al; Mechanism of Motion of an Optical Fiber Aligned by a Solder Droplet; Mat. Res. Soc. Symp. Proc. Vol. 531 pp 95-100 (1998) Materials Research Society							
	2.	Effect of Temperature on Surface Tension; Intelligent Systems Laboratory, Michigan State University, 1999 pp 1-2.						
	3.	Ki-Chang Song et al; Micromachined Silicon Optical Bench for the Low Cost Optical Module.						
	4.	Phillip G. Wapner et al; Utilization of surface tension and wettability in the design and operation of microsensors; Sensors and Actuators B71 (2000) pp 60-67						
	5.	R.R.A. Syms et al; Improving yield, accuracy and complexity in surface tension self-assembled MOEMS; Sensors and Actuators A 88 (2001) pp 273-283.						
	6.	Junghoon Lee at al; Surface-Tension-Driven Microactuation Based on Continuous Electrowetting; Journal of Microelectromechanical Systems, Vol. 9, No. 2. June 2000, pp 171-180.						
	7.	Junghoon Lee Process.	et al; <i>Microac</i>	tuation by Co	ntinous Electrowe	etting Phenor	nenon and Sil	icon Deep RIE ·

EXAMINER EXAMINER

DATE CONSIDERED

Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.